

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date July 27, 2006

In re the Application of

Masatake NAKANO

Group Art Unit: 2812

Application No.: 10/500,381

Examiner: S. ISAAC

Filed: June 29, 2004

Docket No.: 120164

For: METHOD OF PRODUCING SOI WAFER AND SOI WAFER

**LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION
OF TIME UNDER 37 C.F.R. §1.136(a) AND
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

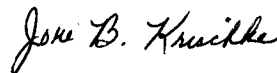
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a Request for Continued Examination in the above-identified patent application. The shortened statutory period having expired June 13, 2006, an extension of time for a period of two months is hereby requested.

The fees associated with this filing under 37 C.F.R. §1.136(a) are being paid electronically with this filing. The Commissioner is hereby authorized to charge any additional fee (or credit any overpayment) associated with this communication to Deposit Account No. 15-0461.

Respectfully submitted,



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<p>DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461</p>
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